

Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10544120	OHBAYASHI ET AL.
Examiner	Art Unit	
JASMINE PRITCHARD	2614	

SEARCHED

Class	Subclass	Date	Examiner
381	174, 175	1/30/2009	J. Pritchard

SEARCH NOTES

Search Notes	Date	Examiner
Inventor name searches: Ohbayashi, Yauda, Saeki, Komai, Kagawa	1/28/2009	J. Pritchard
Oxide and Nitride, silicon film, layers	1/28/2009	J. Pritchard
Personal consultation with Suhan Ni	1/29/2009	J. Pritchard

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner

/JASMINE PRITCHARD/
Examiner.Alt Unit 2614